Docket No.: 043889-0929

2814

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Toyokazu FUJII, et al. : Confirmation Number: 5999

Application No.: 09/536,618 : Group Art Unit: 2814

Filed: March 28, 2000 : Examiner: PHAM, Hoai V.

For: SEMICONDUCTOR DEVICE AND PROCESS FOR FABRICATION OF THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

In accordance with 37 CFR 1.17(p), please charge the fee of \$180.00 to Deposit Account No. 500417.

09/550,018

Each non-English language reference was cited in a corresponding foreign application

search report or office action and its relevance discussed therein. A copy of the foreign search

report or office action, together with an English language version thereof, is attached for the

Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper,

including extension of time fees, to Deposit Account 500417 and please credit any excess fees to

such deposit account.

Respectfully submitted,

McDERMOZT WILL & EMERY LLP

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Date: March 31, 2005

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INFORMATION DISCLOSURE ATTY. DOCKET NO. SERIAL NO. 043889-0929 09/536,618 CITATION IN AN **APPLICATION APPLICANT** Toyokazu FUJII, et al. FILING DATE **GROUP** (PTO-1449) March 28, 2000 2814 **U.S. PATENT DOCUMENTS EXAMINER'S** CITE Document Number Publication Date Name of Patentee or Applicant of Cited Pages, Columns, Lines, Where INITIALS MM-DD-YYYY Relevant Passages or Relevant Document Number-Kind Code2 (# known) Figures Appear 5,160,998 11/03/1992 Itoh et al. บร US 5,545,919 08/13/1996 Ueda et al. US บร บร US ÚS บร US บร US US US ÙS FOREIGN PATENT DOCUMENTS **EXAMINER'S** Foreign Patent Document **Publication Date** Name of Patentee or Pages, Translation INITIALS **Applicant of Cited Document** Columns, Country Codes -Number 4 -Kind Codes (if known) MM-DD-YYYY CITE Yes No ines Where NO. Relevant **Figures** Appear JP 61-287151 12/17/1996 MATSUSHITA JAPAN (w/English ELECTRONICS CORP. Abstract) OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, **EXAMINER'S** INITIALS journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where CITE NO. **EXAMINER** DATE CONSIDERED

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.